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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.

: 10/825,504

Applicant

: Volker Derflinger et al.

Filed

: April 15, 2004

Title

: "WORKPIECE WITH A HARD FILM OF ALCR-CONTAINING

MATERIAL, AND PROCESS FOR ITS PRODUCTION"

Conf. No.

: 8570

TC/A.U.

: 3722

Customer No.

: 00116

Docket No.

: 35885US1

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with Rule 56, applicants are aware of the publications listed in the enclosed copy of Patent Office Form 1449.

It is requested that these references be considered by the Examiner in the examination of the above-identified application.

A copy of the cited references is enclosed herewith.

If there are any further fees resulting from this communication not covered by teh enclosed check, or if no check was enclosed, please charge the same to Deposit Account No. 16-0820, Order No. 35523US1.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Michael W. Garvey
Name of Attorney for Applicant(s)

10-15-2004

Date

Signature of Attorney

Respectfully submitted, PEARNE & GORDON LLP

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October 15, 2004

Form PTO-1449

*Examiner:

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

BY APPLICANT

ATTY. DOCKET NO. 35523US1 SERIAL NO. 10/825,504

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APPLICANT: Volker Derflinger et al.

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U.S. PATENT DOCUMENTS Filing Date Examiner Document No. Class Subclass Date Name Appropriate Initial B C D E F G FOREIGN PATENT DOCUMENTS Country Document No. Date Class Subclass **Translation** Η 1 186 681 A1 8/2001 EP Cited in Spec. Cited in Spec. I 09-041127 8/1995 JP J K OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.) R Thin films (Proc. 4 in. Sympos. Trends & New Applications of Thin Films 1993) DGM Info. Sges., Oberursel 1993, p 73. Surface & Coatings Technology vol. 165, 2 (2003) p. 163-167. Oxidation Resistance of Cr. S Al, N and Ti, Al, N films. Surface & Coating Technoloy vol. 163-164 (2003) p. 57-61. High-Temperature Oxidation Resistance of $Cr_{l-x}A1_xN$ Thin Films Deposited by Reactive Magnetron Sputtering. T U J. Vac. Sci. Technol. A 20(2), Mar/Apr 2002, p. 569-571. Microhardness and Lattice Parameter of Cr_{1-x}A1_xN Films. Surface & Coating Technology, vol. 163-164 (2003) p. 546-551. Abrasive Wear Tsting of DLC Coatings deposited on plane and Cylindrical Parts. Tribologie-Fachtagung 2000, moers: Ges. F. Tribol. 2002, ISBN 3-00-003404-8, W Investigations of Mechanical and Tribological Properties of CrAIN + C Thin Coatings Deposited on Cutting Tools. **Date Considered** Examiner:

Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.